

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: **TSAI, John C.**  
For (title): **SYSTEM FOR ROTATION MEASUREMENT WITH LASER**  
5 **INTERFEROMETRY**

Filing Date: **20/08/2004**  
Serial No: **10/711,090**

Examiner: **LYONS, MICHAEL A.**  
Art Unit: **2877**

10 Mail Stop Non-Fee Amendment  
Honorable Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313

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**RESPONSE TO OFFICE ACTION AND AMENDMENT**

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Sir:

In response to the Office Action dated 11/06/2006, Applicant submits the following remarks and amendment, currently due on a statutory period for response now extending through 02/06/2007.